

Notice of References Cited	Application/Control No. 10/671,966		Applicant(s)/Patent Under Reexamination SCHNEIDER ET AL.	
	Examiner MICHELE C. CHOI		Art Unit 2164	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,374,271	04-2002	Shimizu et al.	715/207
*	B	US-6,154,600	11-2000	Newman et al.	386/4
*	C	US-2004/0054627 A1	03-2004	Rutledge, David R.	705/050
*	D	US-6,570,587 B1	05-2003	Efrat et al.	715/723
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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